Application/Control No.	Applicant(s)/Patent under Reexamination
10/005,713	ITOH ET AL.
Examiner	Art Unit
David G. Cervetti	2136

SEARCHED				
Class	Subclass	Date	Examiner	
713	200	3/11/2005	DGC	
719	319	3/11/2005	DGC	
719	328-332	3/16/2005	DGC	
717	168-178	3/16/2005	DGC	
713	191	3/16/2005	DGC	
713	165	3/16/2005	DGC	
713	ALL	3/11/2005	DGC	
380	ALL	3/11/2005	DGC	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Consulted w/ Chris Revak regarding search strategy	3/11/2005	DGC
Consulted w/ Arani Taghi regarding search	3/8/2005	DGC
Consulted w/ Nguyen-Ba (AU 2122), suggested 719/328-332, 717/168-178, 713/191,165	3/16/2005	DGC
searched IEEE/ACM/Google Scholar	3/16/2005	DGC